

EE 330 Homework 5 Solutions

1. Length of interconnect = 60um
Width of interconnect = 0.6um
No. of squares = $200/2 = 100$.

Sheet resistance of interconnect = 23.5 Ω /square

Resistance = $23.5 * 100 = 2350\Omega$

Capacitance from interconnect to substrate

Capacitance of Poly 1 substrate from the table given = 84aF/um²

Interconnect area = $0.6 * 60 = 36\text{um}^2$

Capacitance of the substrate = $84 * 10^{-18} * 36 = 3.024\text{fF}$

Capacitance between metal and interconnect

Capacitance of Poly and Metal1 from the table given = 56aF/um²

Area of contact between poly and metal = 36um^2

Capacitance = $56 * 10^{-18} * 36 = 2.016\text{fF}$

2. Length of the interconnect = 300um
Width of interconnect = 2um
No. of squares = $300/2 = 150$.
Resistance = 20 Ω
Sheet resistance = $20/150 = 0.133 \Omega$ /square
Resistivity of copper = $1.72 * 10^{-8} \Omega\text{m}$
Thickness = Resistivity/Resistance = 129.3nm

For Ag =>

Sheet resistance = Resistivity /thickness = $1.59 * 10^{-8} / 12.93 * 10^{-8} = 0.123$

Length = $W * R / R_s = 325\text{um}$

3.

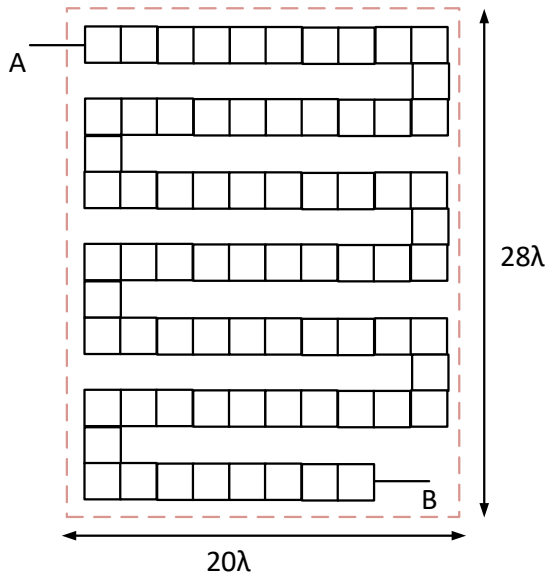
Overlap Cap			
Layers	Overlap Area (μm^2)	aF/(μm^2)	Cap (af)
Poly-Sub	89.1	84	7484.4
M1- Sub	4.86	27	131.22
M2-sub	15.12	12	181.44
M3-Sub	5.4	3	16.2
M1-Poly	24.3	56	1360.8
M2-Poly	25.92	15	388.8
M3-Poly	12.42	9	111.78
M2-M1	9.72	31	301.32
M3-M1	4.86	13	63.18
M3-M2	6.48	35	226.8
Fringe Cap			
Layers	Length (μm)	aF/(μm)	Cap (af)
Poly-Sub	37.8	0	0
M1- Sub	9	49	441
M2-sub	15.6	33	514.8
M3-Sub	9.6	23	220.8
M1-Poly	5.4	59	318.6
M2-Poly	7.2	38	273.6
M3-Poly	3.6	28	100.8
M2-M1	5.4	51	275.4
M3-M1	3.6	34	122.4
M3-M2	7.2	52	374.4

4. Sheet resistance for high resistance poly = $44\Omega/\square$

Resistance = 3000Ω

No. of squares = $3000/44 = 68$

$L = 3W$; Let's use a $2\lambda \times 2\lambda$ for one square. The following layout is approximately 68 squares and the bounding rectangle meets the aspect ratio requirements.

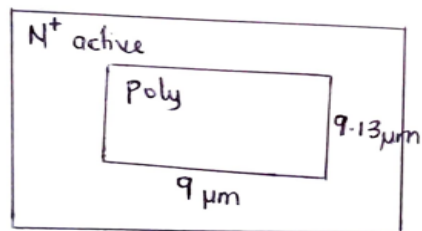


Problem 5.

Designing a capacitor using N^+ active and Poly 1

$$\rightarrow C = C_p \times \text{Area} \rightarrow 200 \times 10^{-15} = 2434 \times 10^{-18} \times A$$

$$\rightarrow \text{Area} = \frac{200 \times 10^{-15}}{2434 \times 10^{-18}} = 82.17 \mu\text{m}^2$$



Problem 6

$$\text{Nominal Value of resistance} = \rho \cdot \frac{\text{Length}}{\text{Area}}$$

From table/calculator relating ρ to resistivity

$$\rightarrow \rho = 22.34 \Omega \cdot \text{cm} = 22.34 \times 10^{-2} \Omega \text{m}$$

$$\rightarrow \text{height (thickness)} = 0.1 \mu\text{m}$$

$$\rightarrow \text{Area} = 0.4 \mu\text{m}^2$$

$$\text{Length} = 50 \mu\text{m}$$

$$\Rightarrow \text{Nominal Value of resistance} = \frac{50}{0.4 \times 10^{-6}} \times 22.34 \times 10^{-2}$$

$$= 27.925 \text{ M}\Omega$$

7. Part A:

Begin by calculating the number of squares in each serpentine structure. We can calculate the number of horizontal lines in the serpentine structures as follows:

$$N_{\text{Horizontal}} = \frac{\text{Length}_{\text{die}}}{\text{Width}_{\text{Interconnect}} + \text{Width}_{\text{Spacing}}} = \frac{1\text{cm}}{0.2\mu\text{m}} = 50000$$

So we have 50,000 horizontal lines, each 1cm long. This amounts to 5×10^9 squares.

To connect these lines, we have $N_{\text{Horizontal}} - 1$ vertical segments, each 0.1μ wide. This amounts to 49,999 squares.

In total, we have $5 \times 10^9 + 49999$ squares per resistor. Each metal layer has a resistivity of $0.12\Omega/\text{sq}$, so each resistor has a resistance of $600\text{M}\Omega$. When combined in parallel, we have a resistance of $200\text{M}\Omega$.

Part B:

Each resistor is only $0.1\mu\text{m}$ thick, so each can carry a maximum density of $150\mu\text{A}$. Placed in parallel, this means the total resistor can carry up to $450\mu\text{A}$.

Part C:

$$P = I^2 R = [450\mu\text{A}]^2 [200\text{M}\Omega] = 40.5\text{W}$$

Problem 8 If the resistance in the interconnect is neglected, it acts as a capacitor in parallel with the input capacitance of the second inverter. $C_I = (C_D)(WL)$

$$a) R_{pd} = 2K \quad t_{HL} = R_{pd}(C_L) \quad C_D = 27 \text{ af}/\mu^2$$

$$C_I = (.6\mu)^2 (27 \text{ af}/\mu^2)$$

$$= 9.7 \text{ aF}$$

$$C_L = 3 \text{ fF} + 9.7 \text{ aF} \approx 3.01 \text{ fF}$$

$$\therefore t_{HL} \approx 6.02 \text{ psec}$$

$$b), \text{ If } L = 200\mu$$

$$C_I = (.6)(200) 27 \text{ af}/\mu^2 = 3.24 \text{ fF}$$

$$\therefore C_L = 3 \text{ fF} + 3.24 \text{ fF} = 6.24 \text{ fF}$$

$$\therefore t_{HL} = (2K)(6.24 \text{ fF}) = 12.5 \text{ psec}$$

c) The only change with poly (again neglecting the interconnect resistance) is $C_D = 84 \text{ af}/\mu^2$

so $C_I = (.6)(200)84 \text{ af}/\mu^2 = 10.1 \text{ fF}$ so $C_L = 13.1 \text{ fF}$ and thus $t_{HL} = (2K)(10.1 \text{ fF}) = 20.2 \text{ psec}$